

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takeshi Fukada                      Art Unit : Unknown  
Serial No. : New Divisional Application      Examiner : Unknown  
Filed : September 8, 2003  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE  
SAME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/296,042, filed on April 21, 1999. The attached list of references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 8, 2003

  
\_\_\_\_\_  
John F. Hayden  
Reg. No. 37,640

**Customer No. 26171**  
Fish & Richardson P.C.  
1425 K Street, N.W., 11th Floor  
Washington, DC 20005-3500  
Telephone: (202) 783-5070  
Facsimile: (202) 783-2331

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-256002	Application No. New Divisional Application
	Applicant Takeshi Fukada		
	Filing Date September 8, 2003	Group Art Unit	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001/0018097	08/2001	Itoh			
	AB	4,448,491	05/1984	Okubo			
	AC	5,101,288	03/1992	Ohta et al.			
	AD	5,176,791	01/1993	Itoh et al.			
	AE	5,461,501	10/1995	Sato et al.			
	AF	5,536,950	07/1996	Liu et al.			
	AG	5,652,029	07/1997	Itoh			
	AH	5,686,980	11/1997	Hirayama et al.			
	AI	5,706,067	01/1998	Colgan et al.			
	AJ	5,724,107	03/1998	Nishikawa et al.			
	AK	5,766,696	06/1998	Itoh			
	AL	5,784,201	07/1998	Lee et al.			
	AM	5,820,947	10/1998	Itoh			
	AN	5,871,847	02/1999	Itoh			
	AO	5,879,741	03/1999	Itoh			
	AP	5,989,672	11/1999	Hayashi			
	AQ	6,001,431	12/1999	Itoh et al.			
	AR	6,110,542	08/2000	Miyanaga et al.			
	AS	6,115,090	09/2000	Yamazaki			
	AT	6,163,055	12/2000	Hirakata et al.			
	AU	6,165,582	12/2000	Hayashi			
	AV	6,171,674	01/2001	Yamazaki et al.			
	AW	6,183,816	02/2001	Yamazaki et al.			
	AX	6,194,047	02/2001	Hayashi			
	AY	6,207,281	03/2001	Itoh			
	AZ	6,217,661	04/2001	Hirose et al.			
	AAA	6,224,952	05/2001	Itoh			

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-256002	Application No. New Divisional Application
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Takeshi Fukada	
		Filing Date September 8, 2003	Group Art Unit

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	ABB	6,258,434	07/2001	Hayashi			
	ACC	6,261,634	07/2001	Itoh			
	ADD	6,265,070	07/2001	Itoh			
	AEE	6,423,383	07/2002	Hirose et al.			
	AFF	6,468,617	10/2002	Yamazaki et al.			

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AGG	03-072711	11/1991	Japan				
	AHH	03-185425	08/1991	Japan				
	AII	04-027691	05/1992	Japan				
	AJJ	10-268360	10/1998	Japan				
	AKK	Hei 11-52	03/1999	Japan				

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	ALL	
	AMM	
	ANN	
	AOO	
	APP	
	AQQ	
	ARR	
	ASS	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	